

RCE
IFW



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No. 29936/39510

REQUEST FOR CONTINUED EXAMINATION (RCE) TRANSMITTAL

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is a Request for Continued Examination (RCE) under 37 C.F.R. §1.114 of the following application:

Application

Application Serial No:	10/699,438
Filed on:	October 31, 2003
Inventors:	Young-Hee Mun, Kun Kim, Chung Geun Koh, and Seung Ho Pyi
Title:	Silicon Wafers and Method of Fabricating the Same
Art Unit:	2822
Examiner:	Maria F. Guerrero
Attorney Docket No.:	29936/39510

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this Request for Continued Examination (RCE) is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Commissioner for Patents, Mail Stop RCE, P.O. Box 1450, Alexandria, VA 22313-1450, on March 14, 2006.

James P. Zeller

1. Submission required under 37 C.F.R. §1.114

- a. Previously submitted
- i. Please consider the arguments and enter the amendments to the claims in the Amendment "B" After Final Rejection filed February 13, 2006.
- ii. Other
- b. Enclosed
- i. Amendment/Reply
- ii. Affidavit(s)/Declaration(s)
- iii. Supplemental Information Disclosure Statement (IDS)
- iv. Other:

2. Fees

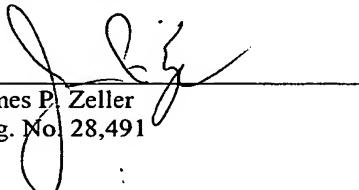
- Check in the amount of \$790.00 is enclosed.

Please direct all future communications to James P. Zeller, at the address below.

Respectfully submitted,

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By:


James P. Zeller
Reg. No. 28,491

March 14, 2006